



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 5573

SERIAL NUMBER 10/723,285	FILING DATE 11/25/2003 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. MAN-013
-----------------------------	---------------------------------------	--------------	------------------------	-----------------------------------

APPLICANTS

Peter Werner, Halle, GERMANY;

Viatcheslav Egorov, St. Petersburg, RUSSIAN FEDERATION;
Vadim Talalaev, St. Petersburg, RUSSIAN FEDERATION; George Cirlin, St. Petersburg, RUSSIAN
FEDERATION;
Nikolai Zakharov, Halle, RUSSIAN FEDERATION;

** CONTINUING DATA ***** NONE SWC

** FOREIGN APPLICATIONS ***** SWC
EUROPEAN PATENT OFFICE (EPO) 02 026 698.7 11/29/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **
** 02/25/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	GERMANY	10	25	2
Examiner's Signature <i>John W. Lorne SWC</i>	Initials			

ADDRESS

28661
SIERRA PATENT GROUP, LTD.
1657 Hwy 395, Suite 202
Minden, NV
89423

TITLE

Semiconductor structure for use in the near infrared region and a method of manufacturing this semiconductor structure

☐ All Fees☐ 1.16 Fees (Filing)